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P. 001

JAPAN AND INTERNATIONAL
PATENT, TRADEMARK AND
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TO: USPTO
Examiner Ms. Paulette R. Kidwell

FAX No.: 571-273-9024

FROM: Konomi Takeshita (Miki Yamaguchi)

DATE: March 29, 2006

Application No. 10/516,849

Our Ref.: Y04S022

MESSAGE: Please see attached.

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P. 002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Kenichiro Miyahara

Docket Number:

Serial No.: 10/516,849

Y04S022

Filed: January 7, 2005

Group art Unit: 2874

FOR: SUBSTRATE FOR FORMING THIN FILM
FORMATION, THIN FILM SUBSTRATE,
OPTICAL WAVEGUIDE, LIGHT
EMITTING DEVICE SUBSTRATE FOR
LIGHT EMITTING DEVICE MOUNTING

Examiner:

Paulette R. Kidwell

Office of Initial Patent Examination

Filing receipt Corrections

Facsimile number 571-273-9024

Attention: Ms. Paulette R. Kidwell

REQUEST FOR CORRECTION


Dear Ms. Kidwell:

Per our recent discussion over the telephone, I am writing to request corrections to be made to the filing receipt issued in connection with the above-stated patent application. Following is the list of correction information. Please also refer to the attached sheets for the correct information.

1. Applicant's address is miss-spelled. (It should be spelled "Kanagawa".)
2. There is one priority information missing. (JP2002-340619 11/25/2002)
3. The title should read as follows:
"SUBSTRATE FOR FORMING THIN FILM FORMATION, THIN FILM
SUBSTRATE, OPTICAL WAVEGUIDE, LIGHT EMITTING DEVICE
SUBSTRATE FOR LIGHT EMITTING DEVICE MOUNTING."

Thank you for your assistance.

Respectfully submitted,

By 
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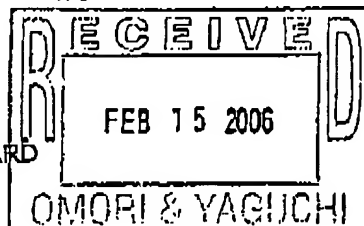


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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FILE FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/516,849	01/07/2005	2874	475	Y04S022	52	3	3

35910
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CONFIRMATION NO. 7212

FILING RECEIPT

Date Mailed: 02/09/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Kenichiro Miyahara, Kanagawa, JAPAN;

↳ It should be spelled "Kanagawa".

Power of Attorney: The patent practitioners associated with Customer Number 35910.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP03/08520 07/04/2003

Foreign Applications

JAPAN 2002-199567 07/09/2002
JAPAN 2002-216336 07/24/2002
JAPAN 2002-271053 09/18/2002
JAPAN 2002-271081 09/18/2002
JAPAN 2002-300848 10/15/2002
JAPAN 2002-320048 11/01/2002
JAPAN 2002-362763 12/13/2002
JAPAN 2003-186175 06/30/2003
JAPAN 2003-186373 06/30/2003

Following priority information is missing:

JAPAN 2002-340619 11/25/2002

Projected Publication Date: 05/18/2006

Non-Publication Request: No

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Early Publication Request: No

Title ^{formation} Substrate for forming thin film, thin film substrate, optical waveguide, ^{light emitting device} luminescent element and substrate for ~~carrying luminescent element~~ ^{one word} light emitting device mounting.

Preliminary Class 385

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Almost every country has its own patent law, and a person desiring a patent in a particular country must make an application for patent in that country in accordance with its particular laws. Since the laws of many countries differ in various respects from the patent law of the United States, applicants are advised to seek guidance from specific foreign countries to ensure that patent rights are not lost prematurely.

Applicants also are advised that in the case of inventions made in the United States, the Director of the USPTO must issue a license before applicants can apply for a patent in a foreign country. The filing of a U.S. patent application serves as a request for a foreign filing license. The application's filing receipt contains further information and guidance as to the status of applicant's license for foreign filing.

Applicants may wish to consult the USPTO booklet, "General Information Concerning Patents" (specifically, the section entitled "Treaties and Foreign Patents") for more information on timeframes and deadlines for filing foreign patent applications. The guide is available either by contacting the USPTO Contact Center at 800-786-9199, or it can be viewed on the USPTO website at <http://www.uspto.gov/web/offices/pac/doc/general/index.html>.

For information on preventing theft of your intellectual property (patents, trademarks and copyrights), you may wish to consult the U.S. Government website, <http://www.stopfakes.gov>. Part of a Department of Commerce initiative, this website includes self-help "toolkits" giving innovators guidance on how to protect intellectual property in specific countries such as China, Korea and Mexico. For questions regarding patent enforcement issues, applicants may call the U.S. Government hotline at 1-866-999-HALT (1-866-999-4158).

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Title 37, Code of Federal Regulations, 5.11 & 5.15

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